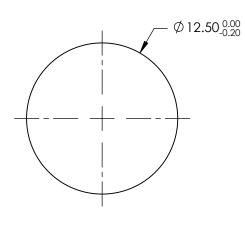
- SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 420 - 2000nm T(AVG): < 1% FROM 200 - 375nm T(ABS): = 50% @ 400nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

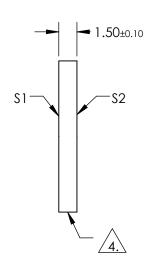
## 4. FINE GRIND SURFACE

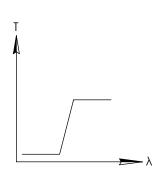
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

PARTS TO THIS DRAWING





LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

			Edmund Optic	\$S®
THIRD ANGLE (		TITLE	OD2, Ø12.5mm, 400nm LONGPASS FI	LTER
ALL DIMS IN	mm	DWG NO	49024	SHEET

- 1. SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC

3. COATING (APPLY ACROSS COATING APERTURE)

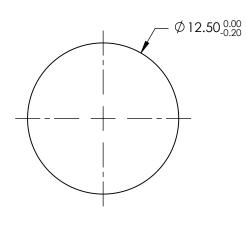
PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 470 - 2000nm T(AVG): < 1% FROM 200 - 430nm

T(ABS): = 50% @ 450nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

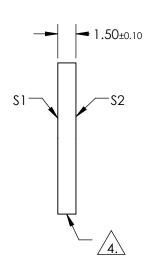
## 4.\ FINE GRIND SURFACE

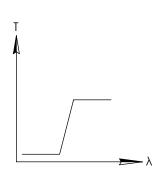
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

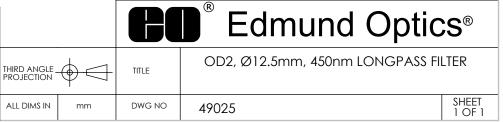
PARTS TO THIS DRAWING





LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED



- 1. SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

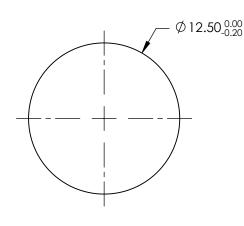
PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 520 - 2000nm T(AVG): < 1% FROM 200 - 480nm

T(ABS): = 50% @ 500nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

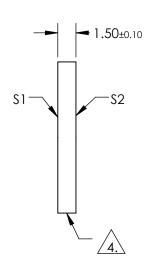
## 4.\ FINE GRIND SURFACE

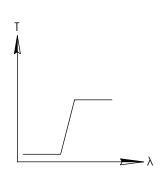
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

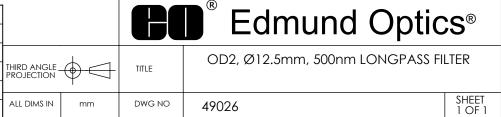
PARTS TO THIS DRAWING

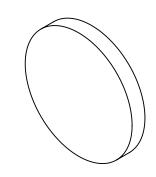




LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED





- 1. SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

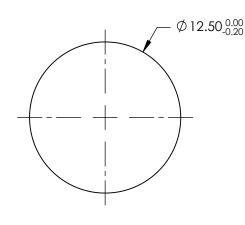
PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 575 - 2000nm T(AVG): < 1% FROM 415 - 515nm

T(ABS): = 50% @ 550nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

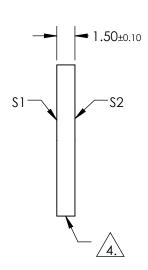
## 4.\ FINE GRIND SURFACE

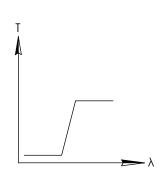
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

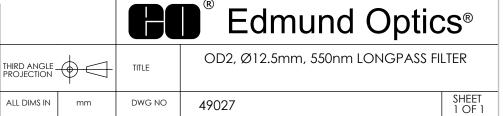
PARTS TO THIS DRAWING

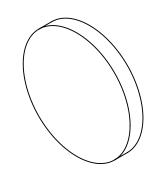




LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED





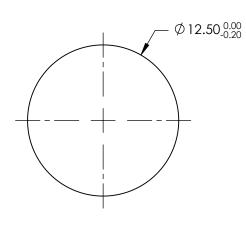
- SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 625 - 2000nm T(AVG): < 1% FROM 460 - 570nm T(ABS): = 50% @ 600nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

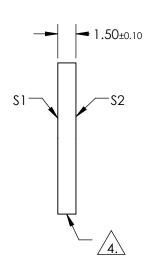
## 4. FINE GRIND SURFACE

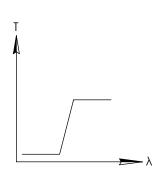
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

PARTS TO THIS DRAWING





LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

			Edmund Optics®		
THIRD ANGLE _ PROJECTION	$\phi$	TITLE	OD2, Ø12.5mm, 600nm LONGPASS FI	LTER	
ALL DIMS IN	mm	DWG NO	49028	SHEET 1 OF 1	

- 1. SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

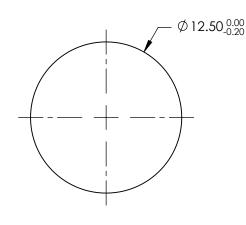
PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 675 - 2000nm T(AVG): < 1% FROM 495 - 610nm

T(ABS): = 50% @ 650nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

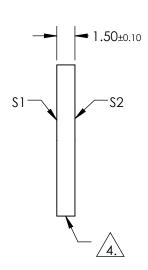
## 4.\ FINE GRIND SURFACE

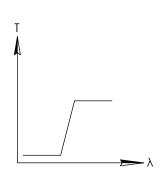
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

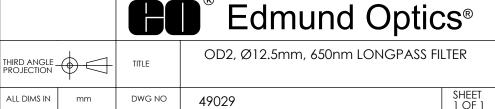
PARTS TO THIS DRAWING





LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED



- 1. SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

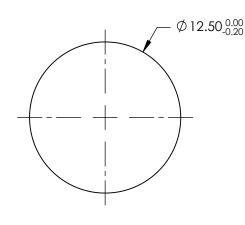
PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 725 - 2000nm T(AVG): < 1% FROM 535 - 660nm

T(ABS): = 50% @ 700nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

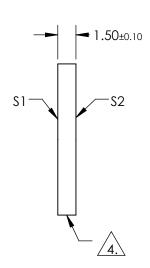
## 4.\ FINE GRIND SURFACE

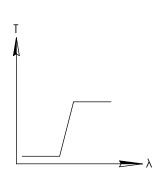
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

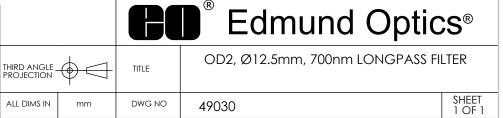
PARTS TO THIS DRAWING

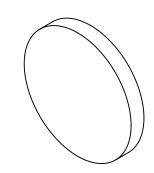




LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED





- 1. SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

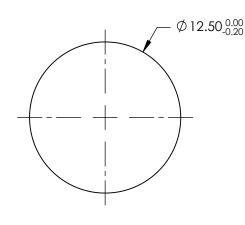
PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 780 - 2000nm T(AVG): < 1% FROM 565 - 715nm

T(ABS): = 50% @ 750nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

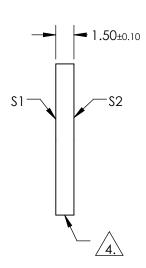
# 4.\ FINE GRIND SURFACE

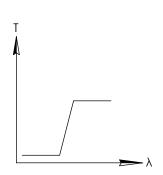
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

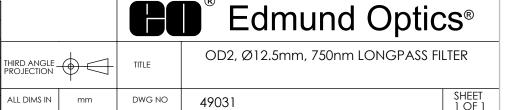
PARTS TO THIS DRAWING

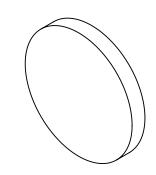




LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED





- 1. SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

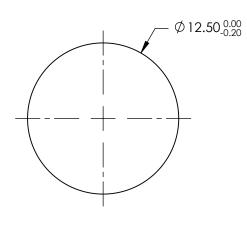
PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 830 - 2000nm T(AVG): < 1% FROM 600 - 760nm

T(ABS): = 50% @ 800nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

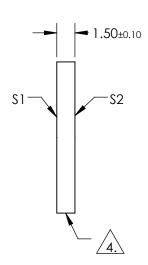
## 4.\ FINE GRIND SURFACE

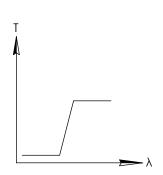
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

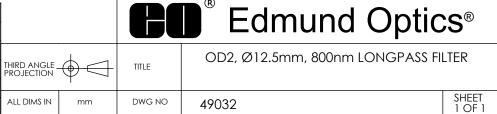
PARTS TO THIS DRAWING

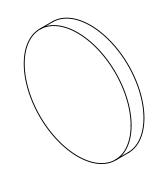




LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED





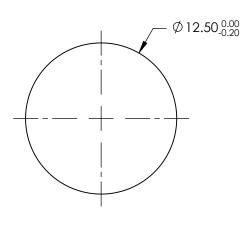
- SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 880 - 2000nm T(AVG): < 1% FROM 635 - 805nm T(ABS): = 50% @ 850nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

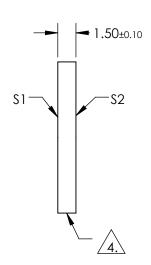
## 4. FINE GRIND SURFACE

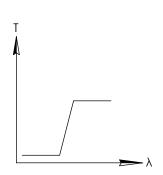
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

PARTS TO THIS DRAWING





LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

			Edmund Optics®		
THIRD ANGLE _ PROJECTION	<b>\$</b>	TITLE	OD2, Ø12.5mm, 850nm LONGPASS FI	LTER	
ALL DIMS IN	mm	DWG NO	49033	SHEET 1 OF 1	

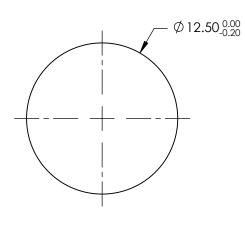
- SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 935 - 2000nm T(AVG): < 1% FROM 675 - 855nm T(ABS): = 50% @ 900nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

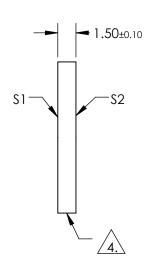
## 4. FINE GRIND SURFACE

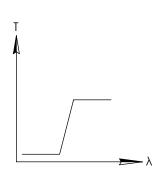
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

PARTS TO THIS DRAWING





LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

			<b>Edmund Optics</b> ®		
THIRD ANGLE PROJECTION		TITLE	OD2, Ø12.5mm, 900nm LONGPASS FI	LTER	
ALL DIMS IN	mm	DWG NO	49034	SHEET 1 OF 1	

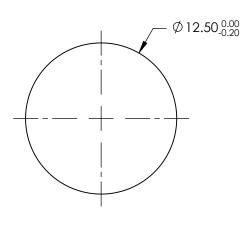
- SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 985 - 2000nm T(AVG): < 1% FROM 715 - 900nm T(ABS): = 50% @ 950nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

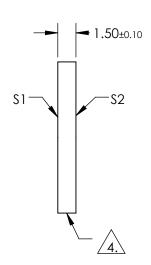
## 4. FINE GRIND SURFACE

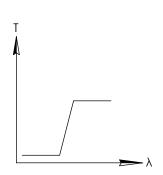
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

PARTS TO THIS DRAWING





LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

			Edmund Optics®		
THIRD ANGLE PROJECTION	<b>\$</b>	TITLE	OD2, Ø12.5mm, 950nm LONGPASS FI	LTER	
ALL DIMS IN	mm	DWG NO	49035	SHEET 1 OF 1	

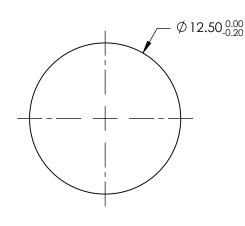
- SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 1035 - 2000nm T(AVG): < 1% FROM 750 - 950nm T(ABS): = 50% @ 1000nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

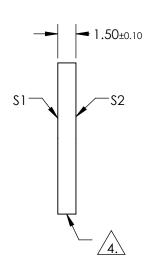
## 4. FINE GRIND SURFACE

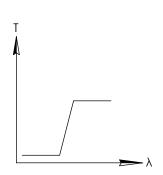
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

PARTS TO THIS DRAWING





LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

			<b>Edmund Optics</b> ®		
THIRD ANGLE PROJECTION		TITLE	OD2, Ø12.5mm, 1000nm LONGPASS F	ILTER	
ALL DIMS IN	mm	DWG NO	49036	SHEET 1 OF 1	

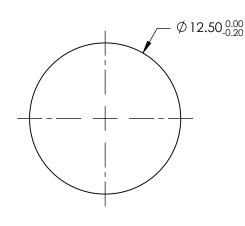
- 1. SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 1085 - 2000nm T(AVG): < 1% FROM 790 - 1000nm T(ABS): = 50% @ 1050nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

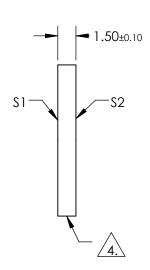
### 4.\ FINE GRIND SURFACE

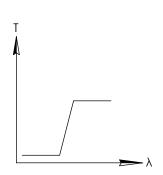
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

PARTS TO THIS DRAWING

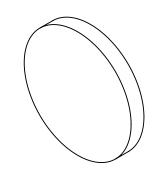




LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED





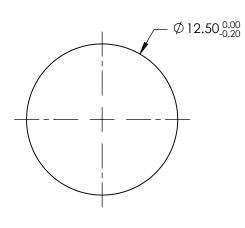
- SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 1135 - 2000nm T(AVG): < 1% FROM 825 - 1045nm T(ABS): = 50% @ 1100nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

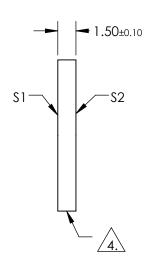
## 4. FINE GRIND SURFACE

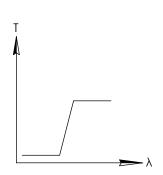
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

PARTS TO THIS DRAWING

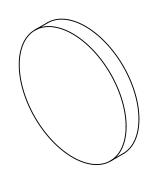




LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

			<b>Edmund Optics</b> ®		
THIRD ANGLE PROJECTION		TITLE	OD2, Ø12.5mm, 1100nm LONGPASS F	ILTER	
ALL DIMS IN	mm	DWG NO	49038	SHEET 1 OF 1	



- 1. SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC

3. COATING (APPLY ACROSS COATING APERTURE)

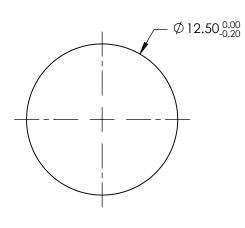
PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 445 - 2000nm T(AVG): < 1% FROM 200 - 405nm

T(ABS): = 50% @ 425nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

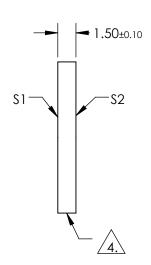
## 4.\ FINE GRIND SURFACE

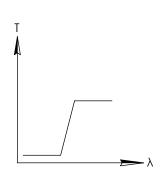
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

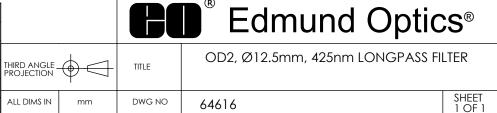
PARTS TO THIS DRAWING

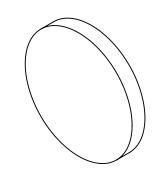




LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED





- 1. SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC

3. COATING (APPLY ACROSS COATING APERTURE)

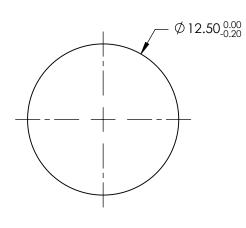
PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 495 - 2000nm T(AVG): < 1% FROM 200 - 455nm

T(ABS): = 50% @ 475nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

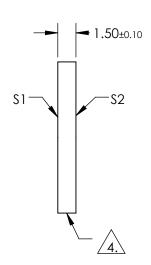
## 4.\ FINE GRIND SURFACE

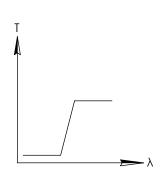
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

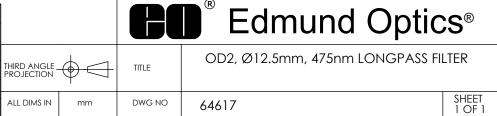
PARTS TO THIS DRAWING

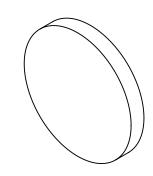




LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED





- 1. SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

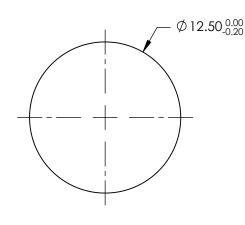
PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 545 - 2000nm T(AVG): < 1% FROM 200 - 505nm

T(ABS): = 50% @ 525nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

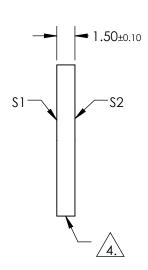
## 4.\ FINE GRIND SURFACE

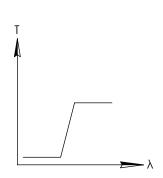
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

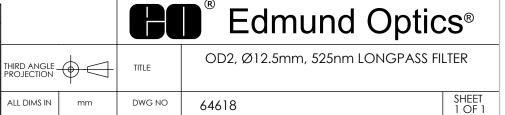
PARTS TO THIS DRAWING

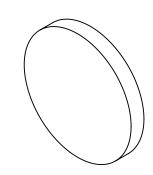




LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED





- 1. SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC

3. COATING (APPLY ACROSS COATING APERTURE)

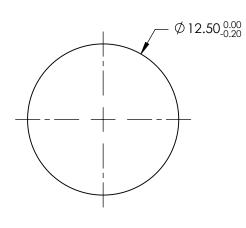
PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 600 - 2000nm T(AVG): < 1% FROM 440 - 540nm

T(ABS): = 50% @ 575nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

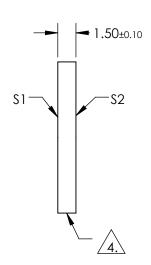
## 4.\ FINE GRIND SURFACE

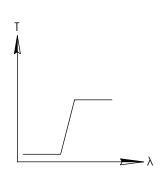
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

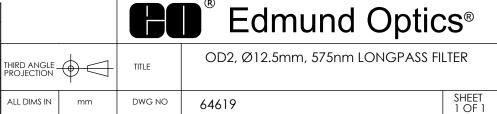
PARTS TO THIS DRAWING





LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED



- 1. SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC

3. COATING (APPLY ACROSS COATING APERTURE)

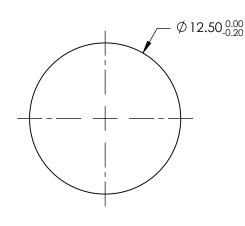
PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 650 - 2000nm T(AVG): < 1% FROM 485 - 595nm

T(ABS): = 50% @ 625nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

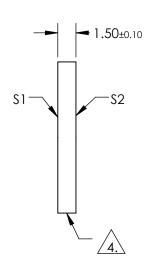
## 4.\ FINE GRIND SURFACE

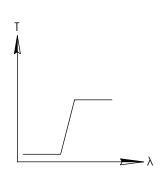
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

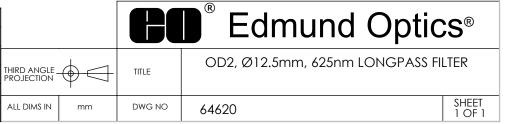
PARTS TO THIS DRAWING

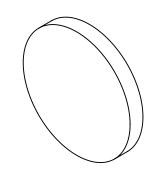




LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED





- 1. SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

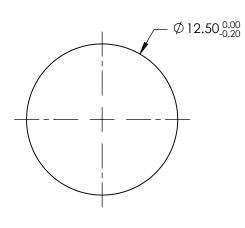
PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 700 - 2000nm T(AVG): < 1% FROM 520 - 635nm

T(ABS): = 50% @ 675nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

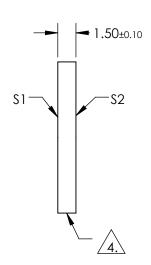
## 4.\ FINE GRIND SURFACE

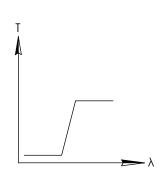
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

PARTS TO THIS DRAWING





LONGPASS FILTER

BEVEL

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00

PROTECTIVE AS NEEDED | PROTECTIVE AS NEEDED



- SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

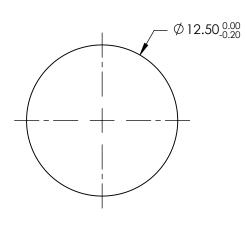
PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 750 - 2000nm T(AVG): < 1% FROM 560 - 685nm

T(ABS): = 50% @ 725nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

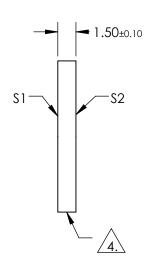
## 4.\ FINE GRIND SURFACE

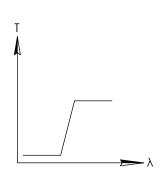
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

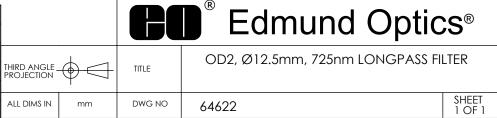
PARTS TO THIS DRAWING





LONGPASS FILTER

	\$1	\$2	
SHAPE	PLANO	PLANO	
SURFACE QUALITY	40-20	40-20	
CLEAR APERTURE	80%	80%	
COATING APERTURE	Ø11.00	Ø11.00	
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	



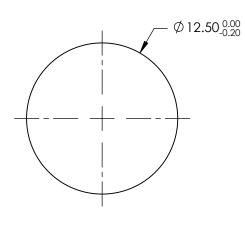
- SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 805 - 2000nm T(AVG): < 1% FROM 590 - 740nm T(ABS): = 50% @ 775nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

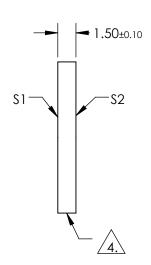
## 4. FINE GRIND SURFACE

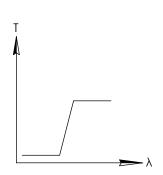
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

PARTS TO THIS DRAWING





LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

			Edmund Optic	S <sup>®</sup>
THIRD ANGLE _ PROJECTION		TITLE	OD2, Ø12.5mm, 775nm LONGPASS FI	LTER
ALL DIMS IN	mm	DWG NO	64623	SHEET 1 OF 1

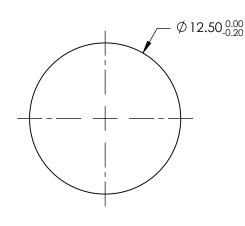
- SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 855 - 2000nm T(AVG): < 1% FROM 625 - 785nm T(ABS): = 50% @ 825nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

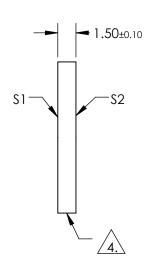
## 4. FINE GRIND SURFACE

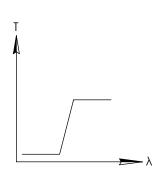
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

PARTS TO THIS DRAWING





LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

			<b>Edmund Optic</b>	S <sup>®</sup>
THIRD ANGLE _ PROJECTION		TITLE	OD2, Ø12.5mm, 825nm LONGPASS FI	LTER
ALL DIMS IN	mm	DWG NO	64676	SHEET 1 OF 1

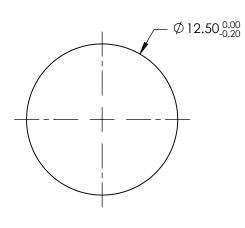
- SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 910 - 2000nm T(AVG): < 1% FROM 660 - 830nm T(ABS): = 50% @ 875nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

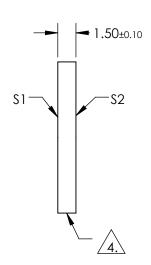
## 4. FINE GRIND SURFACE

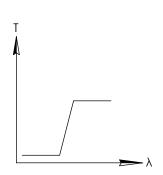
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

PARTS TO THIS DRAWING

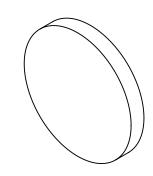




LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

			Edmund Optic	S <sup>®</sup>
THIRD ANGLE _ PROJECTION	<b>\$</b>	TITLE	OD2, Ø12.5mm, 875nm LONGPASS FI	LTER
ALL DIMS IN	mm	DWG NO	64677	SHEET 1 OF 1



- 1. SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

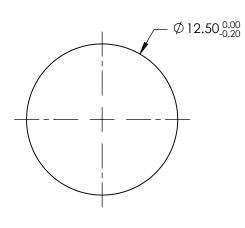
PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 960 - 2000nm T(AVG): < 1% FROM 700 - 880nm

T(ABS): = 50% @ 925nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

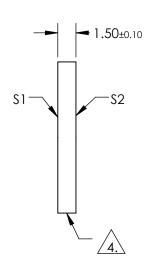
## 4.\ FINE GRIND SURFACE

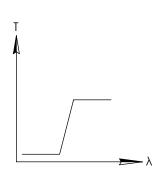
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

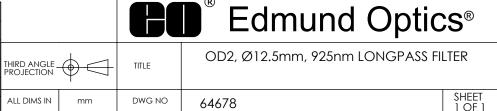
PARTS TO THIS DRAWING





LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED



- 1. SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

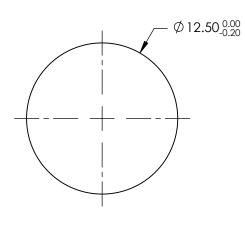
PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 1010 - 2000nm T(AVG): < 1% FROM 735 - 925nm

T(ABS): = 50% @ 975nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

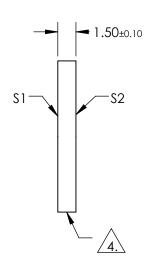
## 4.\ FINE GRIND SURFACE

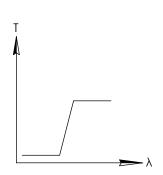
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

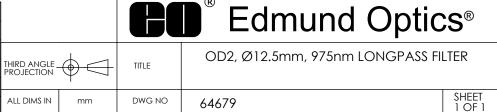
PARTS TO THIS DRAWING

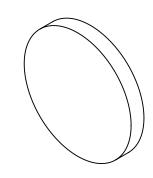




LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED





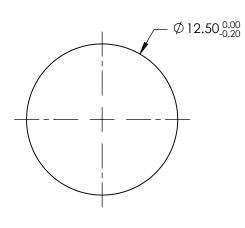
- SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 1060 - 2000nm T(AVG): < 1% FROM 780 - 975nm T(ABS): = 50% @ 1025nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

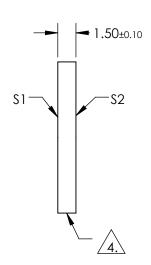
## 4. FINE GRIND SURFACE

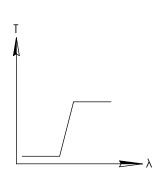
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

PARTS TO THIS DRAWING

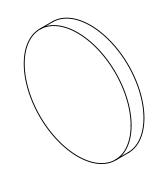




LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

			<b>Edmund Optic</b>	S®
THIRD ANGLE PROJECTION		TITLE	OD2, Ø12.5mm, 1025nm LONGPASS F	LTER
ALL DIMS IN	mm	DWG NO	64680	SHEET 1 OF 1



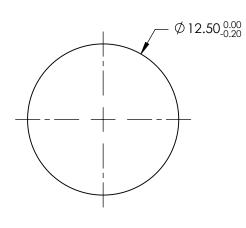
- SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 1110 - 2000nm T(AVG): < 1% FROM 820 - 1025nm T(ABS): = 50% @ 1075nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

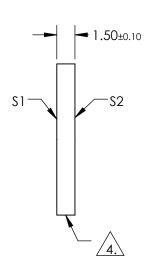
## 4. FINE GRIND SURFACE

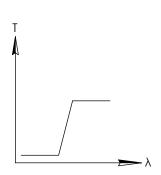
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

PARTS TO THIS DRAWING





LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

			<b>Edmund Optic</b>	S®
THIRD ANGLE PROJECTION		TITLE	OD2, Ø12.5mm, 1075nm LONGPASS F	ILTER
ALL DIMS IN	mm	DWG NO	64681	SHEET 1 OF 1

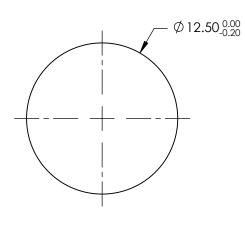
- SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 1160 - 2000nm T(AVG): < 1% FROM 860 - 1070nm T(ABS): = 50% @ 1125nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

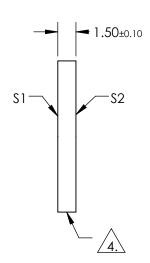
## 4. FINE GRIND SURFACE

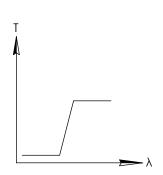
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

PARTS TO THIS DRAWING





LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

			<b>Edmund Optic</b>	S®
THIRD ANGLE PROJECTION		TITLE	OD2, Ø12.5mm, 1125nm LONGPASS F	ILTER
ALL DIMS IN	mm	DWG NO	64682	SHEET 1 OF 1

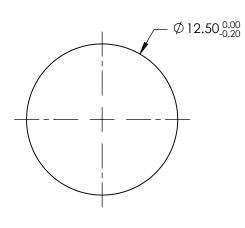
- 1. SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 1190 - 2000nm T(AVG): < 1% FROM 875 - 1095nm T(ABS): = 50% @ 1150nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

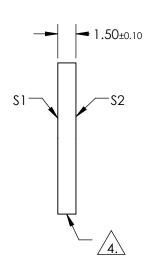
## 4.\ FINE GRIND SURFACE

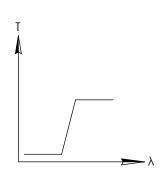
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

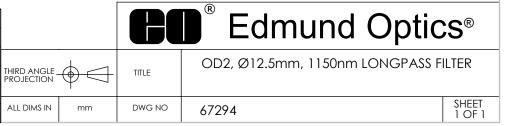
PARTS TO THIS DRAWING

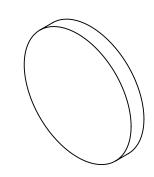




LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED





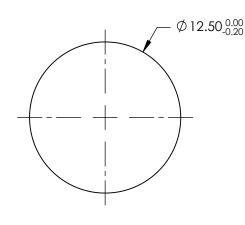
- SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 1215 - 2000nm T(AVG): < 1% FROM 900 - 1120nm T(ABS): = 50% @ 1175nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

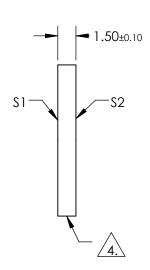
## 4. FINE GRIND SURFACE

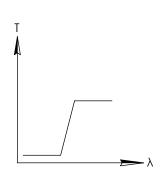
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

PARTS TO THIS DRAWING

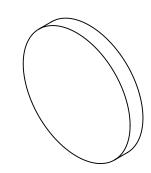




LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

			Edmund Optics®		
THIRD ANGLE PROJECTION		TITLE	OD2, Ø12.5mm, 1175nm LONGPASS F	ILTER	
ALL DIMS IN	mm	DWG NO	67295	SHEET 1 OF 1	



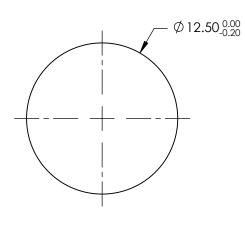
- SUBSTRATE UV GRADE FUSED SILICA
- 2. SURFACE S2 TO BE PARALLEL WITH SURFACE S1 TO WITHIN 5 ARCSEC
- 3. COATING (APPLY ACROSS COATING APERTURE)

PERFORMANCE SPECIFICATIONS @ 0° AOI T(AVG): >85% FROM 1240 - 2000nm T(AVG): < 1% FROM 920 - 1160nm T(ABS): = 50% @ 1200nm

\$1: MULTILAYER DIELECTRIC COATING \$2: SINGLE LAYER MgF2

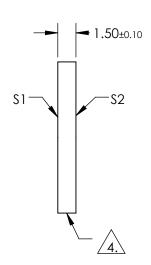
## 4. FINE GRIND SURFACE

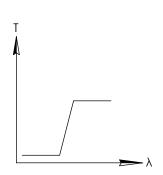
- 5. TRANSMITTED WAVEFRONT DISTORTION RMS@ 632.8nm ≤ 1/4 WAVE
- 6. ROHS COMPLIANT



FOR INFORMATION ONLY:

PARTS TO THIS DRAWING





LONGPASS FILTER

	\$1	\$2
SHAPE	PLANO	PLANO
SURFACE QUALITY	40-20	40-20
CLEAR APERTURE	80%	80%
COATING APERTURE	Ø11.00	Ø11.00
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED

			<b>Edmund Optic</b>	S®
THIRD ANGLE PROJECTION	$\phi \Box$	TITLE	OD2, Ø12.5mm, 1200nm LONGPASS F	LTER
ALL DIMS IN	mm	DWG NO	67296	SHEET 1 OF 1

